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10/016,054	12/06/2001	David J. Nelson	83186WRZ	4831
7590 04/01/2005			EXAMINER	
Milton S. Sales			LIANG, LEONARD S	
Patent Legal Staff			ART UNIT	PAPER NUMBER
Estman Kodak Company 343 State Street				TAI BR NOWDER
			2853	
Rochester, NY 14650-2201			DATE MAILED: 04/01/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/016,054	NELSON ET AL.				
Office Action Summary	Examiner	Art Unit				
	Leonard S. Liang	2853				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period we failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	66(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days fill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).				
Status						
1)⊠ Responsive to communication(s) filed on 30 December 2a)⊠ This action is FINAL. 2b)□ This 3)□ Since this application is in condition for allowant closed in accordance with the practice under Expression 1.	action is non-final. ace except for formal matters, pro-					
Disposition of Claims						
 4) Claim(s) 1-50 is/are pending in the application. 4a) Of the above claim(s) 16-25,47 and 48 is/ar 5) Claim(s) is/are allowed. 6) Claim(s) 1-15, 26-46, 49, and 50 is/are rejected 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or 	e withdrawn from consideration.					
Application Papers		•				
9) The specification is objected to by the Examine	r.					
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.						
Applicant may not request that any objection to the	drawing(s) be held in abeyance. See	e 37 CFR 1.85(a).				
Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Ex						
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicati ity documents have been receive i (PCT Rule 17.2(a)).	on No ed in this National Stage				
Attachment(s)	•					
1) Notice of References Cited (PTO-892)	4) Interview Summary	·				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	atent Application (PTO-152)				

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DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

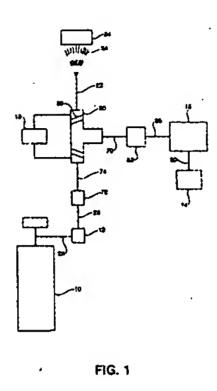
- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 1. Claims 1-4, 6, 10-12, 26-36, 39-40, and 44-46 rejected under 35 U.S.C. 103(a) as being unpatentable over Sievers et al (US Pat 5639441) in view of Coulter (US Pat 3457949).

Sievers et al discloses:

(fig 3, ref 52; column 4, lines 7-9); a discharge device having an inlet and an outlet, a portion of the discharge device defining a delivery path, a portion of the discharge device being adapted to be releasably connected to a pressurized source of a thermodynamically stable mixture of a fluid and a marking material at the inlet, the discharge device being configured to produce a shaped beam of the marking material, the fluid being in a gaseous state at a location beyond the outlet

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of the discharge device (figure 1, reference 20, 22; column 11, lines 44-67; column 12, lines 15-36)



- {claim 10} a predetermined amount of a marking material and a supercritical fluid in a thermodynamically stable mixture, wherein the canister is releasably connectable to a discharge device (figure 1, reference 20)
- {claim 11} A printing apparatus comprising a pressurized source of a thermodynamically stable mixture of a fluid and a marking material (figure 1); a printhead, portions of the printhead defining a delivery path, the delivery path of the printhead being connected to the pressurized source, the printhead including a discharge device, the discharge device having an outlet, a portion of the discharge device being positioned along the delivery path, the discharge device being shaped to produce a shaped beam of the marking material, the fluid being in a gaseous state at a location beyond the outlet of the discharge device
- {claim 12} a receiver retaining device positioned a predetermined distance from the outlet of the discharge device (figure 1, reference 24)

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- {claim 26} a source of fluid connected to the pressurized source (figure 1, reference 10, 14)
- {claim 27} a source of marking material connected to the pressurized source (figure 1, reference 14)
- {claim 28} the pressurized source includes an inlet adapted to receive the marking material (figure 1, reference 30)
- {claim 46} a receiver positioned on a surface of the receiver retaining device (figure 1, reference 24)
- {claims 49-50} the marking material is solvent free when the fluid is in the gaseous state at the location beyond the outlet of the discharging device (column 6, lines 49-51; though Sievers et al does disclose embodiments where a supercritical fluid is mixed with a solvent, it also discloses embodiments where this is not the case, such as when two supercritical fluids are used; in this scenario, the marking material is solvent free when the fluid is in the gaseous state at the location beyond the outlet of the discharging device)

Sievers et al differs from the claimed invention in that it does not disclose:

- {claim 1} a solvent free marking material; an actuating mechanism positioned along the delivery path, the actuating mechanism having a first position removed from the delivery path and a second position in the delivery path
- {claim 2} the discharge device includes a variable area section
- {claim 3} the discharge device includes a constant area section

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- {claim 4} the discharge device includes a first variable area section connected to one end of a first constant area section, and a second variable area section connected to another end of the first constant area section
- {claim 6} the actuating mechanism includes a position controllable actuating mechanism
- {claim 11} a solvent free marking material; an actuating mechanism positioned along the delivery path, the actuating mechanism having an open position at least partially removed from the delivery path
- {claim 29} the discharge device has a variable area section
- {claim 30} the discharge device includes a constant area section
- {claim 31} the discharge device includes a first variable area section connected to one end of a first constant area section, and a second variable area section connected to another end of the first constant area section
- {claim 32} a second constant area section connected to the second variable area section
- {claim 33} the second constant area section having a first predetermined diameter, the second variable area section having a second predetermined diameter, wherein the first predetermined diameter is substantially equal to the second predetermined diameter
- {claim 34} the second predetermined diameter is a maximum diameter of the second variable area section

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- {claim 35} the first constant area section having a third predetermined diameter, the first variable area section having a fourth predetermined diameter, wherein the third predetermined diameter is substantially equal to the fourth predetermined diameter
- {claim 36} the fourth predetermined diameter is a minimum diameter of the first variable area section
- {claim 39} the first constant area section having a predetermined length, wherein the length of the first constant area section is from about 0.1 to about 10 times the diameter of the first constant area section
- {claim 40} the actuating mechanism includes a position controllable actuating mechanism
- {claim 44} the actuating mechanism includes a conical sealing element moveable between the open position and a closed position
- {claim 45} the actuating mechanism includes a discloses shaped sealing element moveable between the open position and a closed position

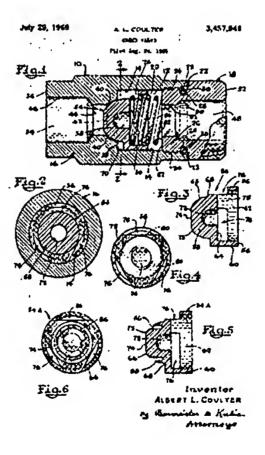
Sievers et al discloses, with respect to claims 1 and 11, mixing a desired solid (i.e. claimed solvent free marking material) with a supercritical fluid (i.e. claimed fluid; column 2, lines 46-63). Sievers et al also discloses "It is an object of this invention to increase the range of substance which can be delivered as fine particles by rapid pressure reduction on a carrier fluid. It is also an object of this invention to increase the range of substances which can be formed into fine particles by supercritical fluid precipitation. At present only substances which are soluble in pressurized or supercritical fluid, with or without the aid of cosolvents and surfactants, are

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amenable to such processes. This invention provides a process for forming fine particles of substances which are soluble in fluids, preferably non-gaseous fluids, immiscible with the pressurized or super-critical fluid. This expands the range of substances which can be delivered and eliminates the need for co-solvents and surfactants." It is clear from this disclosure that the two step process disclosed by Sievers et al is meant to expand and not restrict the field of invention. It is also clear that though the main embodiment of Sievers et al does not disclose a thermodynamically stable mixture of a fluid and a solvent free marking material, Sievers et al does imply that scenario as known in the art.

Coulter discloses

• {claim 1} an actuating mechanism positioned along the delivery path, the actuating mechanism having a first position removed from the delivery path and a second position in the delivery path (figure 1 reference 54)



- {claim 2} the discharge device includes a variable area section (figure 1, reference 40)
- {claim 3} the discharge device includes a constant area section (figure 1, drawn in)

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• {claim 4} the discharge device includes a first variable area section connected to one end of a first constant area section, and a second variable area section connected to another end of the first constant area section (figure 1, reference 40; column 1-6)

- {claim 6} the actuating mechanism includes a position controllable actuating mechanism (figure 1; column 1, lines 12-44)
- {claim 11} an actuating mechanism positioned along the delivery path, the actuating mechanism having an open position at least partially removed from the delivery path (figure 1; column 1, lines 12-44)
- {claim 29} the discharge device has a variable area section (figure 1, reference 40)
- {claim 30} the discharge device includes a constant area section (figure 1; drawn in)
- {claim 31} the discharge device includes a first variable area section connected to one end of a first constant area section, and a second variable area section connected to another end of the first constant area section (figure 1, reference 40; column 1-6)
- {claim 32} a second constant area section connected to the second variable area section (figure 1; drawn in)
- {claim 33} the second constant area section having a first predetermined diameter, the second variable area section having a second predetermined diameter, wherein the first predetermined diameter is substantially equal to the

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second predetermined diameter (figure 1, reference 40; drawn in second constant area)

- {claim 34} the second predetermined diameter is a maximum diameter of the second variable area section (figure 1, reference 40)
- {claim 35} the first constant area section having a third predetermined diameter, the first variable area section having a fourth predetermined diameter, wherein the third predetermined diameter is substantially equal to the fourth predetermined diameter (figure 1, reference 40; drawn in first constant area)
- {claim 36} the fourth predetermined diameter is a minimum diameter of the first variable area section (figure 1, reference 40; segment both minimum and maximum diameter)
- {claim 39} the first constant area section having a predetermined length, wherein the length of the first constant area section is from about 0.1 to about 10 times the diameter of the first constant area section (figure 1)
- {claim 40} the actuating mechanism includes a position controllable actuating mechanism (figure 1; column 1, lines 12-44)
- {claim 44} the actuating mechanism includes a conical sealing element moveable between the open position and a closed position (figure 1, reference 54)
- {claim 45} the actuating mechanism includes a discloses shaped sealing element moveable between the open position and a closed position (figure 2)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Coulter into the invention of Seivers et al.

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The motivation for the skilled artisan in doing so is to gain the benefit of providing a valve which controls the flow of the marking material.

It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Sievers et al. The motivation for the skilled artisan in doing so is to gain the benefit of of forming aerosols and vapors that can be used in a variety of medicinal and industrial uses (column 1, lines 18-26).

2. Claims 5 and 37-38 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sievers et al (US Pat 5639441) in view of Coulter (US Pat 3457949), as applied to claims 1-4, 6, 10-12, 26-36, 39-40, and 44-46, and further in view of Matsumoto et al (US at 5949456).

Sievers et al, as modified, teaches all limitations of the claimed limitation except for the following:

- {claims 5 and 37} the diameter of the first constant area section is from about 20 microns to 2,000 microns
- {claim 38} the diameter of the first constant area section is from about 10 microns to about 20 microns

Matsumoto et al discloses:

- {claims 5 and 37} the diameter of the first constant area section is from about 20 microns to 2,000 microns (column 5, lines 24-25)
- {claim 38} the diameter of the first constant area section is from about 10 microns to about 20 microns (column 5, lines 24-25)

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It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Matsumoto et al into the invention of modified Sievers et al. The motivation for the skilled artisan in doing so is to gain the benefit of having dimensions adequate for proper discharging and proper sealing when the need arises.

Claims 7-8, and 41-42 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sievers et al (US Pat 5639441) in view of Coulter (US Pat 3457949), as applied to claims 1-4, 6, 10-12, 26-36, 39-40, and 44-46, and further in view of Shrivastava et al (US Pat 5461401).

Sievers et al, as modified, teaches all limitations of the claimed limitation except for the following:

- {claims 7 and 41} the actuating mechanism includes a solenoid actuating mechanism
- {claims 8 and 42} the solenoid actuating mechanism is actuable at a plurality of frequencies

Shrivastava et al discloses:

- {claims 7 and 41} the actuating mechanism includes a solenoid actuating mechanism (solenoid valve; abstract; column 1, lines 48-58)
- {claims 8 and 42} the solenoid actuating mechanism is actuable at a plurality of frequencies (abstract; column 1, lines 48-58)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Shrivastava et al into the invention of modified Sievers et al. The motivation for the skilled artisan in doing so is to gain the benefit of

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providing a valve which can regulate the flow of material being discharged through the nozzles and allowing the valve system to obtain higher operating frequencies (abstract).

4. Claims 9 and 43 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sievers et al (US Pat 5639441) in view of Coulter (US Pat 3457949), as applied to claims 1-4, 6, 10-12, 26-36, 39-40, and 44-46, and further in view of Ishikawa et al (US Pat 4739347).

Sievers et al, as modified, teaches all limitations of the claimed limitation except for the following:

• {claims 9 and 43} the position controlling actuating mechanism is positioned adjacent to a solenoid actuating mechanism

Ishikawa et al discloses:

- {claims 9 and 43} the position controlling actuating mechanism is positioned adjacent to a solenoid actuating mechanism (column 3, lines 60-68; column 4)

 It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Ishikawa et al into the invention of modified Sievers et al. The motivation for the skilled artisan in doing so is to gain the benefit of providing a valve to moderate flow control.
- Claims 13-15 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sievers et al (US Pat 5639441) in view of Coulter (US Pat 3457949), as applied to claims 1-4, 6, 10-12, 26-36, 39-40, and 44-46, and further in view of Wang (US Pat 6145980).

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Sievers et al further teaches the printhead is rigidly connected to the pressurized source such that the printhead is stationary (figure 1, reference 22).

Sievers et al, as modified, differs from the claimed invention in that it does not disclose:

- {claim 13} the receiver retaining device being moveably positioned relative to the printhead
- {claim 14} the receiver retaining device is moveable in a first direction and a second direction relative to the printhead
- {claim 15} the second direction is substantially perpendicular to the first direction Wang discloses:
 - {claim 13} the receiver retaining device being moveably positioned relative to the printhead (column 1, lines 60-64; column 3, lines 26-27)
 - {claim 14} the receiver retaining device is moveable in a first direction and a second direction relative to the printhead (column 1 lines 60-64; column 3, lines 26-27)
 - {claim 15} the second direction is substantially perpendicular to the first direction (column 1, lines 60-64; column 3, lines 26-27)

It would have been obvious to one having ordinary skill in the art at the time the invention was made to incorporate the teachings of Wang into the invention of modified Sievers et al. The motivation for the skilled artisan in doing so is to gain the benefit of not needing the complex machine structure of a printhead carriage in order to perform marking on a recording media.

Response to Arguments

Applicant's arguments filed 12/30/04 have been fully considered but they are not persuasive. The applicant argued that the non-final rejection filed on 07/29/04 was identical to the final rejection filed on 02/11/04. However, this is not the case. Though the examiner formed a rejection using the same art as in the final rejection of 02/11/04, a new implicit teaching of Seivers et al was disclosed. The examiner believed that the scope of the original rejection was changed in view of this new implicit teaching and that is why the examiner stated that the applicant's arguments were moot in view of the new grounds of rejection. The examiner has contacted the applicant and made this clear to them. The examiner would now like to give the applicant the opportunity to respond to these new grounds of rejection on the record.

Conclusion

7: THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Leonard S. Liang whose telephone number is (571) 272-2148. The examiner can normally be reached on 8:30-5 Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Lsl L5L 03/30/05

MANISH S. SHAH PRIMARY EXAMINER

3/30/05